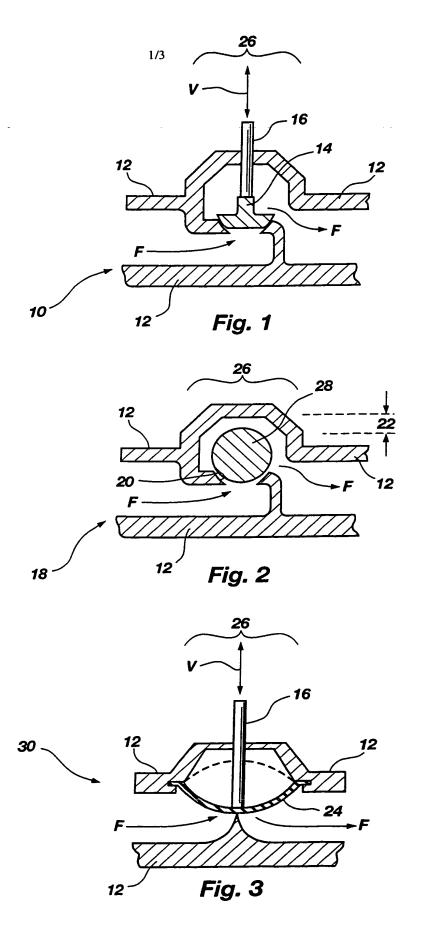
FITLE: METHOD OF REDUCING WATER SPOTTING AND OXIDE GROWTH ON A SEMICONDUCTOR STRUCTURE Inventor: Donald L. Yates Docket No.: 3375.9US



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